

IN THE UNITED ST  In re Application of:  TADAHIRO OHMAR	TATEO -		PATENT A	PPI 10		
In re Application of:	TES PATEN	NT AND TRADEN	ARK OFFICE	- LICAT	<u>ION</u>	
- 44VII L'22	) :			E		
Application No.: 09/494,945 Filed: February 1, 2000	) : )	Examiner: D. I Group Art Unit:	Florez Ruiz			
For: LASER OSCILLATING APPAR EXPOSURE APPARATUS USIN THE SAME, AND DEVICE FABRICATION METHOD	ATUS, )	·· Ont:	2828			
THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450	ì	ecember 8, 2003	***	TECHNOLOGY CE	RECEIVED	e de la companya de l
r: <u>AMEN</u>	<u>DMENT</u>			1 2003 CENTER 2800	ŒD	## ## ## ## ## ## ## ## ## ## ## ## ##

Sir:

In response to the Official Action mailed September 8, 2003, the Examiner is respectfully requested to consider and enter the following amendments.